

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/701,462	ONO, YOSHIHARU	
Examiner	Art Unit	
Kin-Chan Chen	1765	

SEARCHED						
Cla	ass	Subclass	Date		Examiner	
43	38 1	700	7/19/2005		k-cc	
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		706				
		719				
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INTERFERENCE SEARCHED								
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
Epo, Jpo, 78M-70B.	1/18/05	K-1 C			
inventor search	1/8/5-	t-cc			
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